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OFFICIAL

Docket No.: 49677-091

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shinichi YAMAGATA, et al.

Serial No.: 09/925,427

Filed: August 10, 2001

: RESPONSE UNDER 37 CFR 1.116

: EXPEDITED PROCEDURE

: Customer Number: 20277

: Confirmation Number: 5385

: Group Art Unit: 1742

: Examiner: Jenkins, Daniel J.

For: SUBSTRATE MATERIAL FOR MOUNTING A SEMICONDUCTOR DEVICE,
SUBSTRATE FOR MOUNTING A SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE, AND METHOD OF PRODUCING THE SAME

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the Office Action dated December 16, 2003, the Advisory Action dated April 6, 2006 and the Supplemental Advisory Action dated April 14, 2004, reconsideration in light of the following remarks and amendments is respectfully solicited.

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